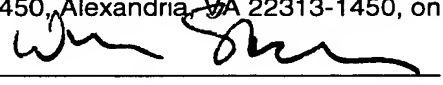


IFW



Docket No.: M&N-IT-439

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By: 

Date: May 4, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/614,429 Confirmation No: 7692
Applicant : Christof Matthias Schilz et al.
Filed : July 7, 2003
Title : Method and Apparatus for Producing Phase Shifter Masks
Art Unit : 1756
Examiner : John S. Ruggles

Docket No. : M&N-IT-439
Customer No. : 24131

R E S P O N S E

Hon. Commissioner for Patents

S i r:

Responsive to the Office Action dated April 12, 2005, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicants elect group II, claims 6-10.

Applicants request a rejoinder under MPEP §821.04.

In view of the foregoing, the early issuance of an Action on the merits of claims 6-10 is solicited.

Respectfully submitted,



For Applicants

WERNER H. STEMER
REG. NO. 34,956

Date: May 4, 2005

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